

Notice of References Cited	Application/Control No. 10/532,672		Applicant(s)/Patent Under Reexamination TAKASE, MICHIIHIKO	
	Examiner Elizabeth Burkhart		Art Unit 1715	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 10-106441	04-1998		Hidaka et al	
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Kim et al, Effects of post-treatment of MgO on the discharge characteristics of an alternating current plasma display panel, J. Vac. Sci. Technol. B 19(3), May/Jun 2001, pp. 687-691.			
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.